


Docket No.: P2002,1010

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Werner H. StemerDate October 20, 2005RECEIVED
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/723,631 Confirmation No: 9710
Applicant : Frank-Michael Kamm
Filed : November 26, 2003
Title : REFLECTION MASK FOR PROJECTING A STRUCTURE ONTO
A SEMICONDUCTOR WAFER AND METHOD FOR PRODUCING
THE MASK
Art Unit : 1756
Examiner : Stephen D. Rosasco

Docket No. : P2002,1010
Customer No. : 24131

RESPONSE

Hon. Commissioner for Patents

Sir:


Responsive to the Office Action dated September 26, 2005, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicant elects group I, claims 1-5 for prosecution at this time.

Applicant requests a rejoinder of the non-elected claims upon the conclusion of the prosecution of claims 1-5.

In view of the foregoing, the early issuance of an Action on the merits of claims 1-5 is solicited.

Respectfully submitted,


Werner H. Stemer (34,956)

Date: October 20, 2005

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